

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<p style="text-align: center;">INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i></p> <p style="text-align: center;">NOV 28 2004</p> <p style="text-align: center;"><i>S. Dulpe</i></p>			Docket Number (Optional) YKI-0078		Application Number 09/966,692	
			Applicant(s) Yamada et al.			
			Filing Date 09/28/2001		Group Art Unit 2812	

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<i>S. Dulpe</i>		6,373,187	04/16/2002	Nagayama et al.			

U.S. PATENT APPLICATION PUBLICATIONS

EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
<i>S. Dulpe</i>	JP 10-321372	1998.12.04	Japan				
<i>S. Dulpe</i>	JP 2000-200680	2000.07.18	Japan				

OTHER DOCUMENTS *(Including Author, Title, Date, Pertinent Pages, Etc.)*

		Office Action for Korean Patent Application No. 10-2001-0059939 dated October 28, 2003

EXAMINER	<i>S. Dulpe</i>	DATE CONSIDERED	<i>12/23/04</i>
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